REMARKS

In accordance with the foregoing, claims 18-20 have been added and are deemed patentable due at least to their depending from corresponding claims 1, 16, and 17. No new matter has been added. Claims 1-20 are pending and under consideration.

REJECTIONS UNDER 35 U.S.C. §102:

In the Office Action at pages 2-3, the Examiner rejects claim 17 under 35 U.S.C. §102 in view of <u>Dekker</u> (U.S. Patent No. 2002/0003762). This rejection is respectfully traversed and reconsideration is requested. In view of the Examiner withdrawal of the rejection in the Advisory Action of July 25, 2006, it is respectfully submitted that claim 17 is in condition for allowance.

REJECTIONS UNDER 35 U.S.C. §103:

On pages 3-8 of the Office Action, the Examiner rejects claims 1-3 and 7-16 under 35 U.S.C. §103(a) in view of <u>Dekker</u> and <u>Ichihara</u> (U.S. Patent 6,396,792). This rejection is respectfully traversed and reconsideration is requested.

On pages 4-5 of the Office Action, the Examiner admits that <u>Dekker</u> does not disclose a leading one of the pulses having a low level and a power level between an end of the second multi-pulse and a first pulse of the first multipulse. In order to cure this deficiency, the Examiner relies upon <u>Ichihara</u> as suggesting the ability to utilize a plurality of power levels other than the recording level for the erase power level. Further the Examiner asserts that, since col. 11, lines 16-25 and col. 7, lines 1-5 of <u>Ichihara</u> teach using different erase levels for different materials, one skilled in the art would be motivated to experiment with other pulses, such as those used for recording, as part of routine experimentation and optimization.

However, it is noted that all invention is based upon optimization and experimentation. Therefore, in order to prevent the trap of impermissible hindsight, there remains a need to provide evidence of a motivation to make a change to the existing art in a manner which meets the claimed invention. With this in mind, in order to rely upon routine experimentation as a rationale, there needs to be evidence of record that one skilled in the art would have recognized that alteration of the power levels of both the first erasure pulse and a pulse between the sequences 13 and 14 would improve erasures or otherwise be known to be beneficial. MPEP 2144.05(II)(B). It is respectfully submitted that the Examiner has not provided such evidence, and that the combination at best suggests altering power levels within the same erasure pattern.

Specifically, to the extent experimentation is suggested, <u>Ichihara</u> teaches experimenting with erasure pulse power levels to promote erasures. As such, col. 11, lines 16-25 and col. 7, lines 1-5 pertains only to alterations of erasure pulse levels. There is no suggestion in <u>Ichihara</u> that the same experimentation should be applied to other pulses, such as recording pulses, since the problem being solved in <u>Ichihara</u> relates to failure to erase problems shown in FIG. 1E. (Col. 8, lines 7-20 of <u>Ichihara</u>). Indeed, it is noted that <u>Dekker</u> also suggests adjusting bias levels of the erasure pulses to have levels P1 or P2 as a function of speed to reduce jitter. (Paragraph 0009 of <u>Dekker</u>). There is no suggestion that a similar benefit is conferred by adjusting recording pulses, adjusting the power level of pulses between the pulse sequences 13, 14, or by changing the entire erasure pattern. As such, neither <u>Dekker</u> nor <u>Ichihara</u> suggest performing the optimization suggested by the Examiner. Thus, <u>Ichihara</u> does not suggest a high power pulse after the erase pulse in combination with a low power lead pulse, low power lead and trailing pulses, or high power lead and trailing pulses.

Moreover, <u>Ichihara</u> teaches away from using a low power lead pulse. Specifically, as is evident from FIGs. 3 and 4 as explained in cols. 8 - 9, the use of the multiple pulses is performed in order to more accurately form erasures and marks. As shown, when initiating an erasure, <u>Ichihara</u> suggests alternating between high and low pulses Pc1, Pc2 in order to promote crystallization growth and nuclei formation. The pulse power levels are due to the different temperatures at which crystals grow and nuclei are generated as shown in FIG. 3. By starting off with a high pulse Pc1 during the initial period Tc1 as shown in FIG. 4, nuclei are formed and then grown. Moreover, this pattern is consistent with the desired temperature profile C shown in FIG. 4, which requires the higher temperature at the beginning of the pattern in order to start the erasure pattern and a lower temperature at the end of the pattern in order to ensure that the erasure pattern ends prior to the next mark. As set forth in col. 9, lines 25-31, this pattern as shown in FIG. 1B is used in order "to ensure the effects of the present invention."

As such, assuming arguendo that different levels for Pc1 and Pc2 can be used for erasure patterns, Ichihara does not suggest that the first pulse should be at a low power level Pc2 (thereby delaying the initiation of the erasure pattern) or that the last pulse be at a high power level Pc1 (thereby extending the erasure pattern into the adjacent mark). Indeed, the pattern suggested in Ichihara is that suggested in Dekker, which also teaches a high power first erasure pulse of the erasure pulse sequence 14. Thus, neither Ichihara nor Dekker suggest another pattern (regardless of power level) in which the first erasure pulse is anything other than a high power level. The Examiner has further not shown evidence from the prior art there is a

suggestion to alter the pattern of both <u>Ichihara</u> and <u>Dekker</u> which would motivate one skilled in the art to revise the pattern of both <u>Ichihara</u> and <u>Dekker</u> in the manner suggested by the Examiner.

In the Advisory Action, the Examiner asserts that col. 6 of <u>Ichihara</u> suggests altering a pulse between a last pulse of a second multipulse and a first multipulse. As a point of clarification, the teachings in col. 6 appear to relate to altering power levels within a common amorphous mark as shown in FIGs. 1A and 1B, but do not discuss or acknowledge any such alteration of a power level between the mark and the space. As such, the alterations suggests in this passage, at best, appear to only suggest altering levels within a common mark.

It is thus respectfully submitted that, even assuming arguendo that <u>Ichihara</u> suggests using other power levels for the shown pulse in FIG. 1B, <u>Ichihara</u> does not suggest altering the overall erasure pattern shown in FIG. 1B such that there remains insufficient evidence as to why one skilled in the art would reverse the power levels in the pattern shown in FIG. 1B of <u>Ichihara</u> in a manner required to meet the features of the recited invention.

Accordingly, it is respectfully submitted that the combination of <u>Ichihara</u> and <u>Dekker</u> does not disclose or suggest, among other features, that "a leading one of the second pulses is set to a low level and a power level between an end of the second multi-pulse and a first one of the pulses of the first multi-pulse is set to a high level" as recited in claim 1. Further, it is respectfully submitted that there is insufficient evidence of a motivation to alter the patterns of <u>Ichihara</u> and <u>Dekker</u> in a manner meeting the features of claim 1 as required to maintain a prima facie obviousness rejection, and that the Examiner has not accounted for evidence of non-obviousness of record in making the rejection.

For at least similar reasons, it is respectfully submitted that the rejection of claims 2, 3 and 7-16 be reconsidered and withdrawn.

For at least similar reasons, it is respectfully submitted that the rejection of claims 2, 3 and 7-11 be reconsidered and withdrawn.

On pages 8-10 of the Office Action, the Examiner rejects claims 1 and 4-6 under 35 U.S.C. §103(a) in view of Seo (U.S. Publication 2002/0101808) and Ichihara. This rejection is respectfully traversed and reconsideration is requested.

In view of the Examiner withdrawal of the rejection in the Advisory Action of July 25, 2006, it is respectfully submitted that claims 1 and 4-6 are in condition for allowance.

CONCLUSION:

There being no further outstanding objections or rejections, it is submitted that the application is in condition for allowance. An early action to that effect is courteously solicited.

Finally, if there are any formal matters remaining after this response, the Examiner is requested to telephone the undersigned to attend to these matters.

If there are any additional fees associated with filing of this Amendment, please charge the same to our Deposit Account No. 503333.

Respectfully submitted,

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